

Notice of References Cited	Application/Control No. 10/590,822		Applicant(s)/Patent Under Reexamination WADA ET AL.	
	Examiner NICOLE IPPOLITO RAUSCH		Art Unit 2881	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0094705	05-2004	Wood et al.	250/288
*	B	US-2007/0054416	03-2007	Regnier et al.	436/518
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shen et al., "Porous Silicon as a Versatile Platform for Laser Desorption/Ionization Mass Spectrometry", Analytical Chemistry 2001, Vol. 73, pp.612-619
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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